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Bib Data Sheet

CONFIRMATION NO. 9739

<b>SERIAL NUMBER</b> 10/733,729	<b>FILING OR 371(c) DATE</b> 12/12/2003 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2818	<b>ATTORNEY DOCKET NO.</b> 4717-9200	
<b>APPLICANTS</b> Walter Schwarzenbach, St. Nazaire Les Eymes, FRANCE; Christophe Maleville, La Terrasse, FRANCE;					
** CONTINUING DATA ***** This appln claims benefit of 60/448,124 02/20/2003					
** FOREIGN APPLICATIONS ***** FRANCE 0216409 12/20/2002					
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 03/17/2004					
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged Examiner's Signature _____ Initials _____		<b>STATE OR COUNTRY</b> FRANCE	<b>SHEETS DRAWING</b> 3	<b>TOTAL CLAIMS</b> 26	<b>INDEPENDENT CLAIMS</b> 4
<b>ADDRESS</b> 28765					
<b>TITLE</b> METHOD OF MAKING CAVITIES IN A SEMICONDUCTOR WAFER					
<b>FILING FEE RECEIVED</b> 1394	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		

12-14-2005